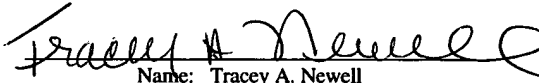


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: :
Hiroto OHTAKE, et al. :
: :
Appln. No.: 10/080,848 : Art Unit: 1765 :
: :
Filed: February 22, 2002 : Examiner: DEO, Duy Vu Nguyen :
: :
For: METHOD OF MANUFACTURING A : Docket No.: KRM-00101 :
SEMICONDUCTOR DEVICE :
CAPABLE OF ETCHING A MULTI- :
LAYER OF ORGANIC FILMS AT A :
HIGH SELECTIVITY :

**Certificate of Mailing**

I hereby certify that the foregoing documents are being deposited with the United States Postal Service as first class mail, in an envelope addressed to the Commissioner for Patents; P.O. Box 1450, Alexandria, VA 22313-1450 on this date of January 25, 2005.


Name: Tracey A. Newell

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Sir:

This is a request to extend the period for filing a response in the above-identified application for one month from January 7, 2005 to February 7, 2005. Enclosed is a check for \$120.00 to cover the extension fee.

Although we believe that we have submitted the correct amount to cover the requested extension of time, the Commissioner is authorized to credit any overpayment or charge any deficiencies to our **Deposit Account No. 031721**. Two originally-executed copies of this form are being submitted.

Should there be any questions after reviewing this paper, the Examiner is invited to contact the undersigned at (617) 248-4038.

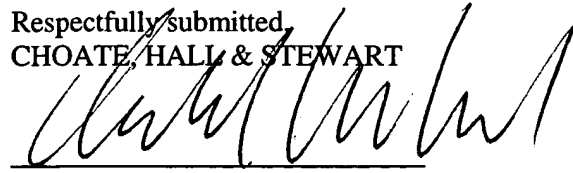
01/31/2005 HAL111 00000056 10080848
01 FC:1251 120.00 0P

January 25, 2005
Date

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3790734_1.DOC

Respectfully submitted,
CHOATE, HALL & STEWART


Donald W. Muirhead
Reg. No. 33,978